Subsurface mechanical damage correlations after grinding of various optical materials

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Abstract. Loose abrasive grinding was performed on a wide range of optical workpiece materials [single crystals of Al₂O₃ (sapphire), SiC, Y₃Al₅O₁₂ (YAG), CaF₂, and LiB₃O₅ (LBO); a SiO₂-Al₂O₃-P₂O₅-Li₂O glass-ceramic (Zerodur); and glasses of SiO₂:TiO₂ (ULE), SiO₂ (fused silica), and P₂O₅-Al₂O₃-K₂O-BaO (phosphate)]. Using the magneto rheological finishing (MRF) taper wedge technique (where a wedge was polished on each of the ground workpieces and the resulting samples were appropriately chemically etched), the subsurface mechanical damage (SSD) characteristics were measured. The SSD depth for most of the workpiece materials was found to scale as \( E_1^{1/2}/H_1 \), where \( E_1 \) is the elastic modulus and \( H_1 \) is the hardness of the workpiece. This material scaling is the same as that for the growth of lateral cracks, suggesting that lateral cracks are a dominant source for SSD rather than radial/median cracks, as previously proposed. Utilizing the SSD depth data from both this study and others, semiempirical relationships have been formulated, which allows for estimating the SSD depth as a function of workpiece material and important grinding parameters (such as abrasive size and applied pressure). © 2019 Society of Photo-Optical Instrumentation Engineers (SPIE) [DOI: 10.1117/1.OE.58.9.092604]

Keywords: optical materials; grinding, lateral cracks; subsurface damage; glass; single crystals; optical fabrication.

1 Introduction
The grinding of brittle materials can be described microscopically as the removal of workpiece particles created from an ensemble of single or intersecting brittle fractures, which are caused by an ensemble of normally loaded, hard indenters or abrasives sliding or rolling across the surface of the workpiece. These microfractures result in the desired outcome of removing material from the surface to shape the workpiece; however, this occurs at the expense of leaving behind subsurface mechanical damage (SSD) that needs to be removed during the subsequent fabrication process steps. In the case of optical components, SSD on the final fabricated optic has been shown to negatively influence its performance (e.g., increasing optical scatter, reducing mechanical strength, and increasing laser damage). Hence understanding the mechanism of SSD creation and predicting the SSD depth has the practical payoff of enabling the development of optical fabrication processes, which minimize and potentially eliminate SSD and therefore lead to the manufacturing of optics both more economically and with better performance.

SSD created during grinding and polishing has been a topic of much study, both in terms of methods to measure as well as to understand its creation. The influence of various grinding parameters, such as abrasive size, depth of cut, and applied pressure, has been investigated. However, due to the complex set of interactions occurring at the workpiece–lap interface, the development of a global quantitative model for grinding SSD has been challenging to develop. Some of these interactions include: (1) the agglomeration, comminution, and/or rotation of the abrasive particles; (2) the presence of rogue particles; and (3) the complex load distribution on the abrasive particles due to its particle size distribution as well as the mechanical properties and surface topology of the workpiece and lap.

In this study, we attempt to lean toward a more global grinding SSD damage model. First, one important parameter not systematically evaluated to date with respect to SSD is the influence of workpiece properties on the SSD depth characteristics. Hence, in this study, the SSD correlations among a wide variety of workpiece materials are evaluated and implications on the mechanisms of SSD creation are described. Second, using SSD data from previous studies, more global semiempirical SSD correlations are developed to estimate SSD depth as a function of various workpiece materials as well as important grinding process parameters (such as, abrasive size and applied pressure). The workpiece materials utilized in this study have also been used as part of a broader study to develop more predictive quantitative relationships during optical fabrication (such as polishing removal rate, grinding removal rate, and grinding surface roughness as a function of workpiece materials) with the aim to enable accelerated development of optical fabrication processes for new workpiece materials.3,4

2 Experimental
2.1 Optical Material Workpieces
Nine different optical workpiece materials were utilized for the grinding experiments: single crystal Al₂O₃ (sapphire) (a-plane, Coastline Optics, Camarillo, California), single crystal SiC (SiC-6H 0001, MTI Corporation, Richmond, California), single crystal Y₃Al₅O₁₂ (YAG) (Northrop
Grumman/Synoptics, Charlotte, North Carolina), single crystal CaF$_2$ (111 orientation, ISP, Irvington, New York), single crystal Li$_2$O$_3$ (LBO) (2ω doubler cut, Coherent Crystal, New Jersey), SiO$_2$-Al$_2$O$_3$-P$_2$O$_5$-Li$_2$O glass ceramic (Zerodur) (Schott, Duryea, Pennsylvania), SiO$_2$:TiO$_2$ glass (ULE) (Corning Inc., Corning, New York), SiO$_2$ glass (Fused Silica) (Corning 7980, Corning Inc., Corning, New York), and P$_2$O$_5$:Al$_2$O$_3$:K$_2$O:BaO glass (phosphate glass) (LHG-8, Hoya Corporation, Milpitas, California). All the samples were 50 mm in diameter and typically 1 cm thick.

2.2 Grinding Experiments

Loose abrasive grinding of each of the workpiece materials was conducted on a 300-mm-diameter flat granite lap utilizing 15-μm Al$_2$O$_3$ abrasive slurries (Microgrit WCA 15T; Universal Photonics, Hicksville, New York). The loose abrasive slurry was prepared as five parts water to one part abrasive powder and fed single pass with a 1.2-mL/min feed rate using a peristaltic pump. The same grinding conditions were used for each of the workpieces, namely: lap rotation of 20 rpm, workpiece rotation of 20 rpm, center offset between workpiece and lap center of 75 mm, and applied pressure on workpiece of 1.1 psi using weights on the workpiece.

2.3 SSD Measurement

The SSD depth and length distributions for each of the workpieces were measured using the magneto rheological finishing (MRF) taper wedge technique. The details of this process are described elsewhere. Figure 1 schematically illustrates the process. After grinding, each workpiece was polished using MRF (QED 22Y, QED, Rochester, New York) using either a cerium oxide-based slurry (C10+) or diamond-based (D10) slurry on a 50-mm MRF wheel using 2751 rpm pump speed and an 18-Amp field intensity. A shallow one-dimensional linear wedge was created ranging in maximum depth from 11 to 150 μm (depending on the amount of SSD observed on a given workpiece) over an area of 20 mm × 30 mm on the workpiece surface. Each of the optical workpieces was then chemically etched ~1 μm; the specific etch process and chemistry are described for each of the workpiece materials in Table 1. Next, the polished portion of each workpiece material was characterized by optical microscopy to view the exposed SSD cracks at various polished depths along the MRF wedge. For the SSD depth distribution, the obscuration of the cracks on the surface, which is proportional to the number density of cracks, as a function of depth into the surface was determined. The crack obscuration was determined via image analysis (by image thresholding and calculating the area of cracks in the field of view) of each of the optical microscopy images along the wedge (corresponding to depth into the workpiece). Note, at low obscurations, multiple images at a given depth were analyzed for improved statistics. For the SSD length distribution, the cumulative distribution of only isolated (not intersecting) crack lengths on the surface at all depths along the wedge combined was determined.

3 Results

A photo of each of the workpiece materials after being ground and polished with a wedge is shown in Fig. 2. Table 1 summarizes the list of workpiece materials evaluated, their relevant material properties, etching parameters, MRF wedge parameters, and the measured SSD results. Chemical etching was performed on each of the wedged workpiece materials in order to reveal any hidden SSD from the surface. Because of the broad range of material types (glasses, single crystals, and glass–ceramics) and material chemistries, a unique etch recipe (composition, concentration, temperature, and etch time) had to be developed in order to practically etch ~1 μm from the workpiece surface. The details of the etch recipes for each workpiece material are described in Table 1. The etching composition varied dramatically such as: buffered oxide etch (NH$_4$F:HF) for the silica-based glasses or glass-ceramics; concentrated base (sodium hydroxide) for the phosphate glass; acetic acid for LBO; hydrochloric acid for CaF$_2$; concentrated potassium hydroxide at elevated temperatures for SiC; and more complex recipes using concentrated sulfuric/phosphoric acid, often at elevated temperatures, followed by a sulfuric acid rinse for the sapphire and YAG single crystals. Successful etching resulted in the exposure of SSD as shown in Fig. 3(a). However, unoptimized etching can easily lead to problems such as thermal fracture during elevated temperature etching followed by lower temperature rinsing [see Fig. 3(b)], anisotropic etching at crystal dislocations [see Fig. 3(c)], and/or redeposition of etch by-products on the workpiece surface [see Fig. 3(d)]. These issues were largely resolved by choosing etch recipes that had elevated temperature rinsing that was slowly ramped down to room temperature reducing the driving force for thermal fracture, slowing down the etch rate to minimize the effect of revealing etched dislocations, and slowing down the etch rate combined with aggressive rinsing to minimize redeposition.

Figure 4 shows example microscope images at fixed depths of 5, 7, and 13 μm along the polished wedge of the ground surfaces for each of the workpieces. The character of the individual microcracks is similar for all the workpieces as observed in previous studies (for example, see Ref. 6); the width of the microcrack is determined by the amount etched.

![Fig. 1 Schematic illustration of the MRF wedge techniques utilized for measured SSD characteristics. (after Refs. 5, 6.)](https://www.spiedigitallibrary.org/journals/Optical-Engineering/092604-2/September-2019-Vol.58(9)Optical-Engineering.092604-2)
### Table 1 List of workpiece materials, basic material properties, etching parameters, MRF wedge parameters, and SSD results.

<table>
<thead>
<tr>
<th>Workpiece material</th>
<th>Composition</th>
<th>Material type</th>
<th>Young's modulus, $E_1$ (GPa)</th>
<th>Knoop hardness, $H_1$ (GPa)</th>
<th>Fracture toughness, $K_{IC}$ (MPa.m$^{0.5}$)</th>
<th>Etch recipe</th>
<th>Temperature (°C)</th>
<th>Etch rate ($\mu$m/h)</th>
<th>Etch time (h)</th>
<th>MRF slurry</th>
<th>Wedge depth ($\mu$m)</th>
<th>SSD depth $10^{-4}$ Obs ($\mu$m)</th>
<th>SSD depth $10^{-5}$ Obs ($\mu$m)</th>
<th>SSD average length ($\mu$m)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Sapphire</td>
<td>$\text{Al}_2\text{O}_3$</td>
<td>Single crystal</td>
<td>345</td>
<td>17.2</td>
<td>3.45</td>
<td>$\text{H}_2\text{SO}_4$; $\text{H}_3\text{PO}_4$; $\text{H}_2\text{SO}_4$</td>
<td>260</td>
<td>1.2</td>
<td>0.3</td>
<td>NA</td>
<td>NA</td>
<td>0</td>
<td>0</td>
<td>NA</td>
</tr>
<tr>
<td>Silicon carbide</td>
<td>SiC</td>
<td>Single crystal</td>
<td>410</td>
<td>27.5</td>
<td>4.6</td>
<td>KOH</td>
<td>480</td>
<td>30</td>
<td>NA</td>
<td>NA</td>
<td>NA</td>
<td>0</td>
<td>0</td>
<td>NA</td>
</tr>
<tr>
<td>YAG</td>
<td>$\text{Y}_3\text{Al}<em>5\text{O}</em>{12}$</td>
<td>Single crystal</td>
<td>300</td>
<td>11.9</td>
<td>2</td>
<td>$\text{H}_2\text{SO}_4$; $\text{H}_3\text{PO}_4$; $\text{H}_2\text{SO}_4$</td>
<td>22</td>
<td>0.03</td>
<td>20.0</td>
<td>D10</td>
<td>40</td>
<td>11.2</td>
<td>20.0</td>
<td>4.5</td>
</tr>
<tr>
<td>Calcium fluoride</td>
<td>$\text{CaF}_2$</td>
<td>Single crystal</td>
<td>76</td>
<td>1.5</td>
<td>0.55</td>
<td>$2.5\text{M HCl}$</td>
<td>22</td>
<td>3.0</td>
<td>0.3</td>
<td>C10+</td>
<td>53</td>
<td>15.1</td>
<td>18.3</td>
<td>12.6</td>
</tr>
<tr>
<td>LBO</td>
<td>$\text{LiB}_2\text{O}_5$</td>
<td>Single crystal</td>
<td>140</td>
<td>6.0</td>
<td>0.54</td>
<td>$0.2\text{M CH}_3\text{COOH}$</td>
<td>22</td>
<td>3.0</td>
<td>0.3</td>
<td>C10+</td>
<td>91</td>
<td>18.0</td>
<td>22.3</td>
<td>14.3</td>
</tr>
<tr>
<td>Zerodur</td>
<td>$\text{SiO}_2$; $\text{Al}_2\text{O}_3$; $\text{P}_2\text{O}_5$; $\text{Li}_2\text{O}$</td>
<td>Glass-ceramic</td>
<td>90.3</td>
<td>6.1</td>
<td>0.9</td>
<td>$\text{NH}_4\text{F}$; $\text{HF}$; 6:1 (3x diluted)</td>
<td>22</td>
<td>1.0</td>
<td>1.0</td>
<td>C10+</td>
<td>150</td>
<td>12.5</td>
<td>15.9</td>
<td>10.3</td>
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<tr>
<td>ULE</td>
<td>$\text{SiO}_2$; $\text{TiO}_2$</td>
<td>Glass</td>
<td>68</td>
<td>4.3</td>
<td>1.43</td>
<td>$\text{NH}_4\text{F}$; $\text{HF}$; 6:1 (10x diluted)</td>
<td>22</td>
<td>3.0</td>
<td>0.3</td>
<td>C10+</td>
<td>36</td>
<td>24.6</td>
<td>27.7</td>
<td>13.5</td>
</tr>
<tr>
<td>Fused silica</td>
<td>$\text{SiO}_2$</td>
<td>Glass</td>
<td>72.7</td>
<td>5.9</td>
<td>0.75</td>
<td>$\text{NH}_4\text{F}$; $\text{HF}$; 6:1 (3x diluted)</td>
<td>22</td>
<td>1.6</td>
<td>0.7</td>
<td>C10+</td>
<td>15</td>
<td>7.5</td>
<td>7.6</td>
<td>11.9</td>
</tr>
<tr>
<td>Phosphate</td>
<td>$\text{P}_2\text{O}_5$; $\text{Al}_2\text{O}_3$; $\text{K}_2\text{O}$; $\text{BaO}$</td>
<td>Glass</td>
<td>50</td>
<td>3.2</td>
<td>0.51</td>
<td>$2\text{M NaOH}$</td>
<td>22</td>
<td>0.8</td>
<td>1.3</td>
<td>C10+</td>
<td>73</td>
<td>30.6</td>
<td>39.4</td>
<td>9.8</td>
</tr>
</tbody>
</table>

NA, not applicable.
and length is determined by the grinding process and workpiece material. The relative areal amount of SSD can be easily visually compared in Fig. 4 by ranking the degree of obscuration (i.e., amount of total crack area in the field of view of the image) at a fixed depth. Hence, phosphate glass clearly had the largest amount of SSD damage, whereas YAG and fused silica had the least amount of SSD damage.

Figure 5 shows the SSD depth distribution in terms of obscuration (which is proportional to crack number density) as a function of depth for all the workpiece materials characterized in this study after grinding with the same 15-μm Al$_2$O$_3$ process. Note the plot is on a semilog scale with the obscuration spanning up to six-orders-of-magnitude. The magnitudes of the SSD depth, arbitrarily defined at an obscuration of 10$^{-4}$ or 10$^{-5}$, are summarized in Table 1. Consistent with the visual observations from Fig. 4, fused silica and YAG had the least amount of SSD depth, and phosphate glass had the deepest SSD.

Similarly, Fig. 6(a) shows the crack length distributions for the same samples but presented as cumulative fraction of analyzed individual cracks. Again, the average crack length for each of the workpieces is summarized in Table 1. Most of the workpieces had similar crack length distributions, except for YAG and LBO. Comparing the average crack length from this study with our previous study Ref. 6, the dominant factor controlling the crack length is the abrasive size rather than the mechanical properties of the workpiece material [see Fig. 6(b)].

Note the 15-μm Al$_2$O$_3$ grinding process did not remove material from SiC and Sapphire, and hence its SSD is reported as zero (see Table 1) and excluded from Figs. 4–6.

4 Discussion

4.1 Correlation Between SSD Depth and Workpiece Material Properties

A key objective of the present study is to determine how basic material properties of the workpiece influence the SSD during grinding. Here, we compare how the SSD depth scales with material scaling factors for basic types of cracks created on the surface. The dominant factors that determine the depth of the cracks during sharp indentation are the mechanical properties of the workpiece and the applied normal load. The relationships that govern the extent
of radial and lateral fracture growth, in isotropic materials following crack initiation, as a function of applied load ($P$) are given by8–10

$$c_r = s_r P^{2/3},$$  \hspace{1cm} (1a)

$$c_l = s_l P^{1/2},$$  \hspace{1cm} (1b)

where $c_r$ and $c_l$ are the crack depths ($\mu$m), and $s_r$ and $s_l$ are the rates of crack growth with scaled load (referred to as crack slope). The subscripts $r$ and $l$ designate radial and lateral cracks, respectively. In a previous study, we measured both the lateral and radial crack depths as a function of the applied load on the same set of optical workpiece materials utilized in this study.11 The load dependence was largely consistent with that described in Eqs. (1a) and (1b); the rate of increase in crack depth as a function of scaled load ($s_r$ or $s_l$) was determined. The growth rate of the crack is known to scale with the material properties of the workpiece, namely $E_{11}/H_1$ for lateral cracks and $(E_1/H_1KIC)^{1/3}$ for radial cracks.1,11,12 Because lateral cracks tend to propagate parallel to the workpiece surface and often break to the surface, they are more inclined to release a chip of the workpiece material. Hence lateral cracks are known to be the dominant crack type leading to material removal, and have been shown to scale with grinding rate and grinding surface roughness.11–13 By the same reasoning, because radial/median cracks propagate perpendicular to the workpiece surface, they have been thought to be the dominant crack type governing SSD depth.5

Figures 7(a) and 7(b) show how well the measured SSD depth for a fixed grinding process scales with both the lateral crack and radial crack material scaling factors. Surprisingly, SSD depth was found to scale much better with the lateral crack scale factor ($E_{11}/H_1$ [Fig. 7(a)]) rather than the radial crack scaling factor $[(E_1/H_1KIC)^{1/3}]$ [Fig. 7(b)] for the workpiece materials evaluated in this study. The SSD depth increased linearly with $E_{11}/H_1$ up to a value of at least 2 GPa$^{-1/2}$. CaF$_2$, which had a high value of $E_{11}/H_1 = 5.8$ GPa$^{-1/2}$, was the only workpiece material that did not follow the trend.

A possible explanation for why lateral cracks, rather than radial cracks, are correlated to SSD depth is because the lateral cracks are actually deeper than the radial cracks. Consider a single sharp abrasive particle normally loaded via static indentation resulting in both radial and lateral cracks as shown in Fig. 8. Figure 8(a) shows the more commonly drawn schematic where radial cracks are deeper than the lateral cracks, and Fig. 8(b) shows the converse where lateral cracks are deeper.

The analysis below evaluates whether it is possible for the lateral cracks to be deeper than the radial cracks. Using the previously measured values for $s_r$ or $s_l$,11 we find that the two are correlated [see Fig. 9(b)], which can be described empirically as

$$s_l = 2.2 s_r^{1/10.8}. \hspace{1cm} (2)$$

Intuitively this means that the rate of increase in lateral crack depth gets larger with increase in the rate of increase in radial crack depth. Hence despite the fact that the depth of
radial cracks has a stronger load dependence than lateral cracks [see Eqs. (1a) and (1b)], the propensity to have deeper lateral cracks is driven by Eq. (2). Using Eqs. (1a), (1b), and (2), Fig. 9(b) shows the calculated crack depth difference between radial and lateral cracks \((c_r - c_l)\) as a function of the radial crack slope \((s_r)\) of the workpiece material for the load range expected on abrasive particles during loose abrasive grinding. A negative value for \(c_r - c_l\) means that
the lateral crack is deeper than the radial crack. The results in Fig. 9(b) suggest that lateral cracks can often be deeper than or nominally equal to the depth of radial cracks in the appropriate load range. This analysis is consistent with the hypothesis that lateral cracks can be deeper than radial cracks, thus explaining why SSD depth was found to scale with the lateral crack depth scaling factor $E_{11}/2H_{1}$, as opposed to the radial crack depth scaling factor. Note, however, at much higher applied loads, the larger load dependence for the radial cracks would start to dominate resulting in deeper radial cracks, as has been historically described.

4.2 Prediction of SSD Depth

As discussed above, the complexity of the grinding process has historically made it challenging to predict SSD depth distributions for various grinding processes and workpiece materials. In this study, the SSD on a broad range of workpiece materials has been measured and evaluated. In a
previous study, the SSD on a broad range of grinding processes on a single workpiece material was measured.\textsuperscript{5,6,14} Some of the results of that study as a function of the major grinding process variables (namely abrasive size and applied pressure) are shown in Figs. 10(a) and 10(b).

Accounting for the workpiece material scaling to SSD depth described in the previous section [see Fig. 7(a)] and the dependency of SSD depth to applied pressure and abrasive size [see Figs. 10(a) and 10(b)], the following...
Semiempirical expression can be used to estimate the amount of SSD depth ($c_{\text{max}}$) for standard grinding processes as

$$c_{\text{max}} = \left( \frac{E_1^{1/2}}{H_1} - C_b \right) \sigma_0^{1/2} d_c^{3/4} - C_c,$$

where $E_1$ is the elastic modulus of workpiece (GPa), $H_1$ is the hardness of workpiece (GPa), $\sigma_0$ is the applied pressure (psi), and $d_c$ is the mean abrasive particle size ($\mu$m) using the constants $C_a = 4.3 \mu m^{1/4} \text{GPa}^{1/2} \text{psi}^{-1/2}$, $C_b = 3.0 \mu m^{1/4} \text{psi}^{-1/2}$, and $C_c = 8.0 \mu m$. The solid lines in Figs. 7 and 10 show that Eq. (3) does a reasonable job of describing the expected SSD depth as a function of workpiece material properties, grinding abrasive size, and grinding applied pressure.

To explore how much influence other grinding process variables have on the SSD depth, a broader set of SSD depth data collected on a host of workpiece materials (including those in Table 1. BK7 glass, Si, Ge, InSb, CdTe, and MgF$_2$) and different grinding processes [including loose and fixed abrasives, different media (Al$_2$O$_3$, diamond, SiC), different kinematics or relative velocities, different applied pressures, and different depths of cut for fixed abrasive grinding], measured by a variety of measurement techniques (including MRF wedge, taper polishing, MRF spot, cross sectioning, and roughness change with etching), were evaluated. 

Figure 11 summarizes all this data of ~150 measurements plotted as SSD depth as a function of abrasive size. The dominant grinding process variable is the abrasive size that influences the SSD depth, with most of the data falling within the band outlined by the dashed lines. Hence despite all the different grinding process changes described, the SSD depth largely stays within the band shown in Fig. 11.

There are a few points outside the band, which are largely attributed to gross rogue particle contamination leading to an increase in SSD depth. It has been previously shown that rogue particle contamination can significantly increase the SSD depth. In other words, the addition of rogue particles effectively increases the abrasive size during grinding resulting in an increase in the load per particle and hence depth of cracking.

The SSD depth band in Fig. 11 can also serve as another useful empirical rule-of-thumb to estimate the range of the amount of SSD that can occur as

$$7.5 \mu m^{1/2} d_c^{3/4} \geq c_{\text{max}} \geq 3.5 \mu m^{1/2} (d_c - 15 \mu m)^{1/2}$$

A likely mechanism influencing the lower end of the SSD depth band (i.e., minimum SSD depth for a given abrasive size) is the ductile-to-brittle transition. In other words, lower applied pressures will at some point lead to an inability for fracture to initiate, thus preventing fracture-induced removal. A likely mechanism influencing the upper end of the SSD depth band (i.e., maximum SSD for a given abrasive size) is the maximum depth-of-cut that can be practically implemented during fixed abrasive grinding. This then defines the maximum applied pressure that can result in practical grinding and hence the maximum load per particle leading to fracture and the maximum SSD depth.

5 Conclusions

For a fixed grinding process, we find that SSD depth scales with $E_1^{1/2}/H_1$ of the workpiece material being processed. This scaling suggests that lateral cracks are an important and possibly the dominant crack type leading to SSD depth. Combining this workpiece material scaling with previous grinding process-dependent SSD depth correlations, useful semiempirical relationships have been determined to aid in estimating the SSD depth for a given workpiece material and grinding process.

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References

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